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A multiscale coupled finite-element and phase-field framework to modeling stressed grain growth in polycrystalline thin films

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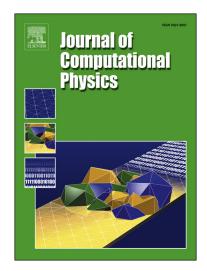
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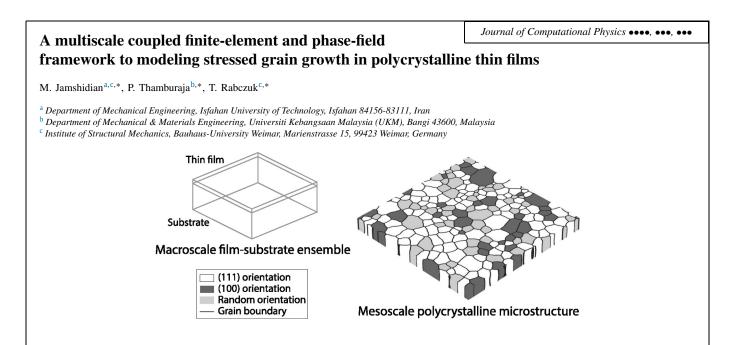
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